



35.C13470

PATENT APPLICATION

1764
#6
11-22-99
Linda
B.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
T. SAWAYAMA ET AL.) Examiner: Not Yet Assigned
Application No.: 09/294,367) Group Art Unit: 1764
Filed: April 20, 1999)
For: PROCESSING APPARATUS,)
EXHAUST PROCESSING)
PROCESS AND PLASMA)
PROCESSING PROCESS) November 16, 1999

Assistant Commissioner for Patents
Washington, D.C. 20231

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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is
directed to the documents listed on the enclosed Form
PTO-1449. Copies of the listed documents are also enclosed.

The concise explanation of relevance for the non-
English documents JP 8-218174 and JP 7-130674 may be found in
the specification at page 6, lines 5-19. An English abstract
of each document is included for the Examiner's convenience.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicants

Registration No. 29,767

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200